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CONFIRMATION NO. 7742

SERIAL NUMBER 10/686,768	FILING DATE 10/17/2003 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. SEC.1034CIP	
APPLICANTS Kyeong-mo Koo, Yongin-City, KOREA, REPUBLIC OF; Ja-hum Ku, Seongnam-City, KOREA, REPUBLIC OF; Hye-jeong Park, Seoul, KOREA, REPUBLIC OF; ** CONTINUING DATA <i>yes n</i> ***** This application is a CIP of 10/457,449 06/10/2003 ABN ** FOREIGN APPLICATIONS <i>yes n</i> ***** REPUBLIC OF KOREA 2002-63567 10/17/2002 REPUBLIC OF KOREA 2003-66498 09/25/2003 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/16/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 16	TOTAL CLAIMS 50	INDEPENDENT CLAIMS 6
ADDRESS 20987 VALENTINE FRANCO, & WHITT PLLC ONE FREEDOM SQUARE 11951 FREEDOM DRIVE SUITE 1260 RESTON, VA 20190					
TITLE Method of forming cobalt silicide film and method of manufacturing semiconductor device having cobalt silicide film					
			<input type="checkbox"/> All Fees		